Doc Code: AP.PRE.REO

PTO/SB/33 (07-05)
Approved for use through xx/xx/200x, OMB 0651-00xx

J.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respon	U.S. Patent a nd to a collection of	nd Trademark Office; of information unless it	U.S. DEPARTMENT OF COMMERCE t displays a valid OMB control number.	
PRE-APPEAL BRIEF REQUEST FOR REVIEW		Docket Number (Optional)		
		TEGL-01165US0		
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail	Application N	umber	Filed	
in an envelope addressed to "Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)]	09/	898,439	07-05-2001	
on	First Named I	Inventor		
Signature		Tue Nguyen		
	Art Unit	E	xaminer	
Typed or printed name	2818		Hoang, Quoc Dinh	
Applicant requests review of the final rejection in the above-identified application. No amendments are being filed with this request.				
This request is being filed with a notice of appeal.				
The review is requested for the reason(s) stated on the attached sheet(s).  Note: No more than five (5) pages may be provided.				
am the				
applicant/inventor.	-		/Michael L. Robbins/	
assignee of record of the entire interest.  See 37 CFR 3.71, Statement under 37 CFR 3.73(b) is enclosed.	Michael L. Robbins			
(Form PTO/SB/96)	Typed or printed name			
attorney or agent of record.  Registration number			415.362.3800 Telephone number	
attorney or agent acting under 37 CFR 1.34.		May	18, 2007	
Registration number if acting under 37 CFR 1.34	_	Iviay	Date	
NOTE: Signatures of all the inventors or assignees of record of the entire interest or their representative(s) are required.  Submit multiple forms if more than one signature is required, see helow.*				

This collection of information is required by 35 U.S.C. 132. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentially is governed by 35 U.S.C. 122 and 37 CPR 1.11, 1.14 and 4.15. This collection is estimated to take 12 minuses to complete, including pathods, including pathods, including pathods, including pathods, including pathods, including pathods, and including pathods are pathods and including pathods. The pathods are pathods are pathods are pathods are pathods are pathods are pathods. The pathods are pathods are pathods are pathods are pathods are pathods. The pathods are pathods are pathods are pathods are pathods are pathods. The pathods are pathods are pathods are pathods are pathods are pathods are pathods. The pathods are pathods. The pathods are pathods. The pathods are pathods

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.

\*Total of \_\_\_\_1

\_\_\_ forms are submitted.

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen

Appln. No.: 09/898,439 Confirm. No.: 1885

Filed: July 5, 2001

Title: PLASMA SEMICONDUCTOR PROCESSING

SYSTEM AND METHOD

## PATENT APPLICATION

Art Unit: 2818

Examiner: Quoc Dinh Hoang

Customer No. 23910

## PRE-APPEAL BRIEF REQUEST FOR REVIEW

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This request is made in reply to the Final Office Action dated December 18, 2006 and is submitted concurrently with a Notice of Appeal.

The requested Review is to focus on rejections and arguments in the previous response dated October 4, 2006.

Claims 30, 35, 36 and 38 were pending in the Application prior to the outstanding Office Action. In the Office Action, the Examiner objected to claims 35 and 36 and rejected claims 30, 35, 36 and 38.

Claims 30 and 38 stand rejected under 35 U.S.C. 102(b) as being anticipated by *Amagasa* (U.S. Patent No. 4,750,077).

Amagasa does not disclose an improved apparatus for semiconductor processing, a helical ribbon electrode, or an electrode coupled to the output of a RF generator, but rather a coil device for use in a dynamo electric machine or for a protection circuit for AC to DC converter. Amagasa discloses an inductive coil with certain value of capacitance to act as a low pass filter in an electrical circuit. In contrast, the present invention discloses an electrode, which is a conductor coupled to the output of a circuit and serves as an antenna to radiate energy from an RF generator. There is no mention of electrode, antenna, or an RF generator in the Amagasa disclosure.

Claims 35 and 36 stand rejected under 35 U.S.C. 103(a) as being unpatentable over *Ye* et al. (U.S. Patent No. 6,488,862) in view of *Amagasa*.

Ye, et al. discloses an apparatus for semiconductor processing, while Amagasa discloses a coil for a dynamo electric machine or for a protection circuit. Amagasa does not mention semiconductor processing, and does not mention an electrode for an RF generator. Thus Applicants submit that the combination of Amagasa to Ye, et al. is improper.

For the above discussed reasons, claims 30, 35, 36 and 38 are believed to be allowable and such is respectfully requested.

The Commissioner is authorized to charge any underpayment or credit any overpayment to Deposit Account No. 06-1325 for any matter in connection with this paper.

Respectfully submitted,

Date: May 18, 2007 By: Michael L. Robbins/

Michael Robbins Reg. No. 54,774

FLIESLER MEYER LLP 650 California St., 14<sup>th</sup> Floor San Francisco, California 94108 Telephone: (415) 362-3800